

APPLN. FILING DATE: JUNE 19, 2001  
TITLE: PLASMA ETCHING OF DIELECTRIC YER...  
INVENTOR(S): TUQIANG NI ET AL.  
APPLICATION SERIAL NO: 09/883,207 SHEET 1 of 1

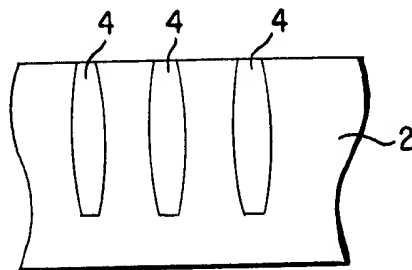


FIG. 1

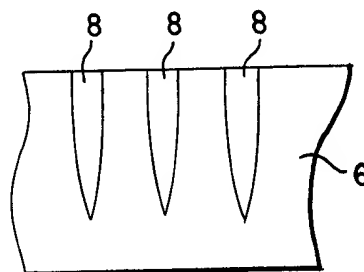


FIG. 2

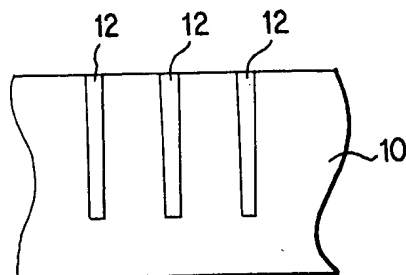


FIG. 3

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